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SEC.63

NEW

Yeong-kwan Kim et al.

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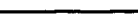
U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	A	Y. Kim et al., "Substrate dependence on the optical properties of Al ₂ O ₃ films grown by atomic layer deposition," Appl. Phys. Lett. 71 (25), 22 December 1997, pages 3604-3606.

EXAMINER

DATE CONSIDERED

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